



**Chapter 17.**

# ***MOSFETs - An Introduction***

**Sung June Kim**

**[kimsj@snu.ac.kr](mailto:kimsj@snu.ac.kr)**

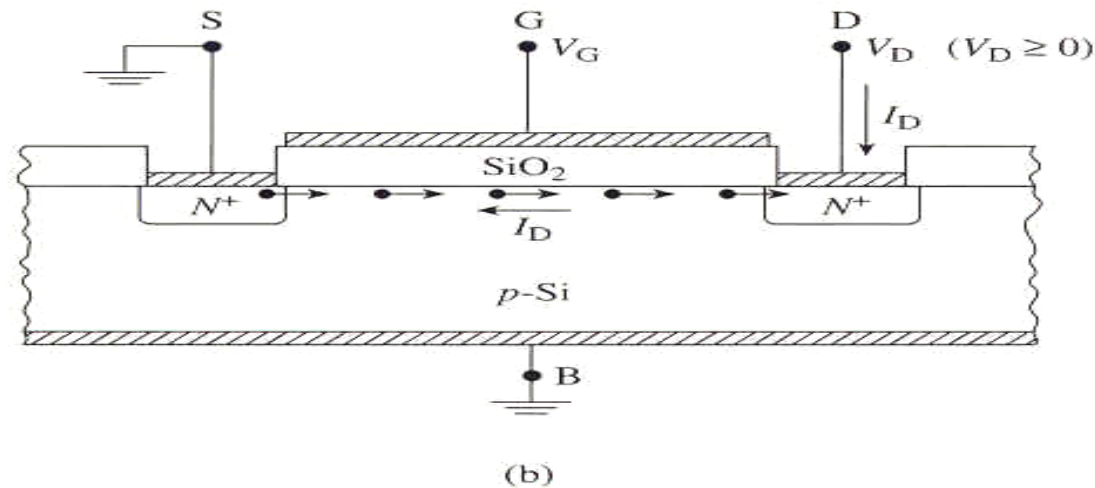
**<http://helios.snu.ac.kr>**

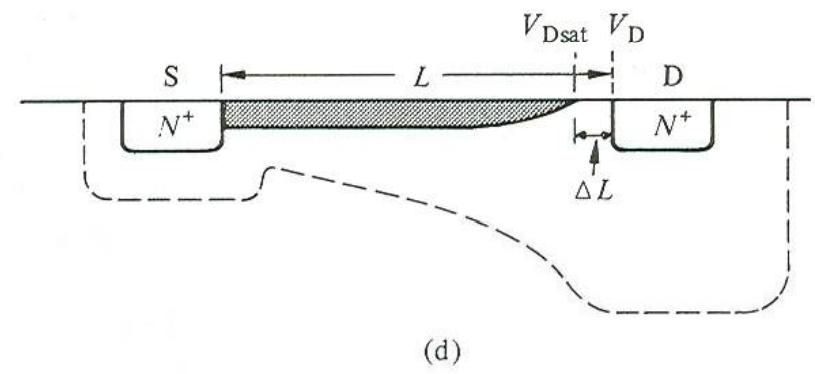
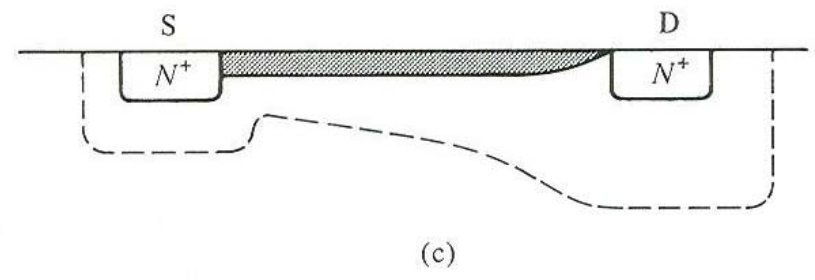
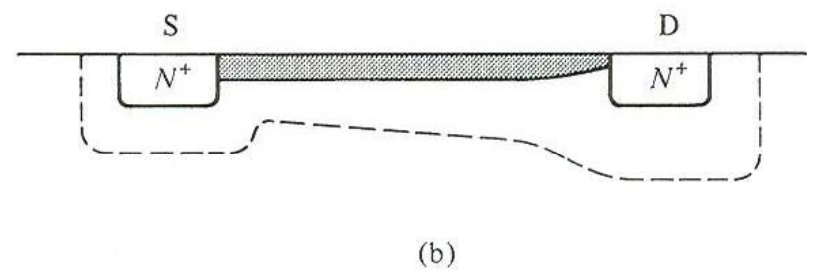
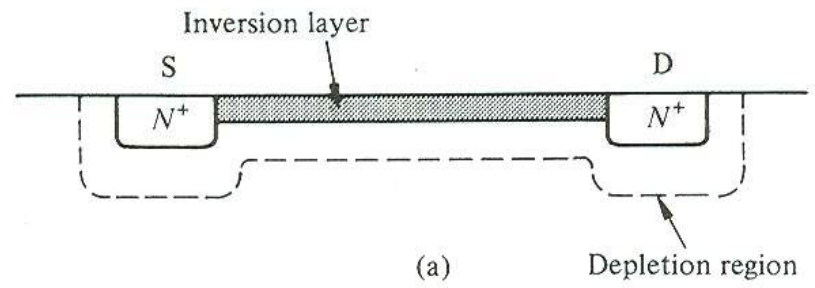
# ***CONTENTS***

- **Qualitative Theory of Operation**
- **Quantitative  $I_D - V_D$  Relationships**
- **Subthreshold Swing**
- **ac Response**

# *Qualitative Theory of Operation*

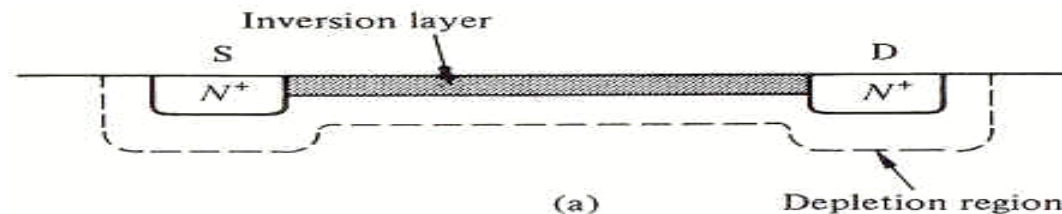
- **Assumption**
  - **Ideal Structure**
  - **Long Channel Enhancement-Mode**
  - **MOSFET=MOS-Capacitor + 2 pn junctions**
  - **n - channel (p-type substrate)**



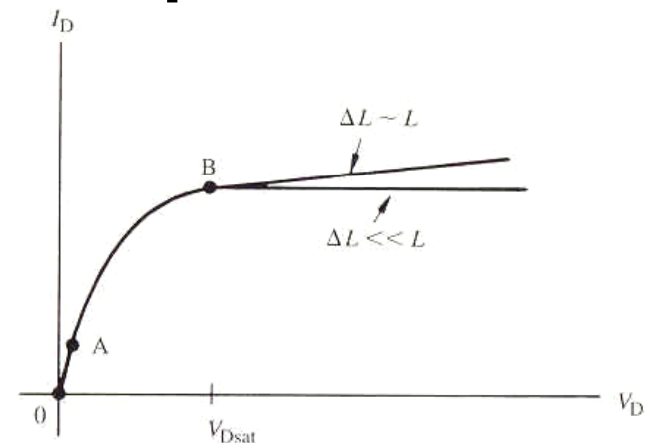
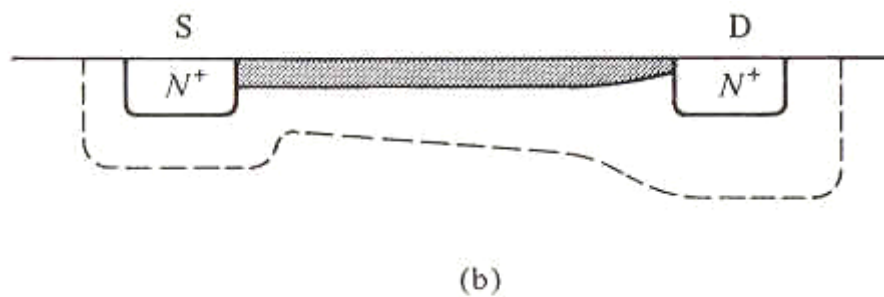


# $V_D = 0$ Case

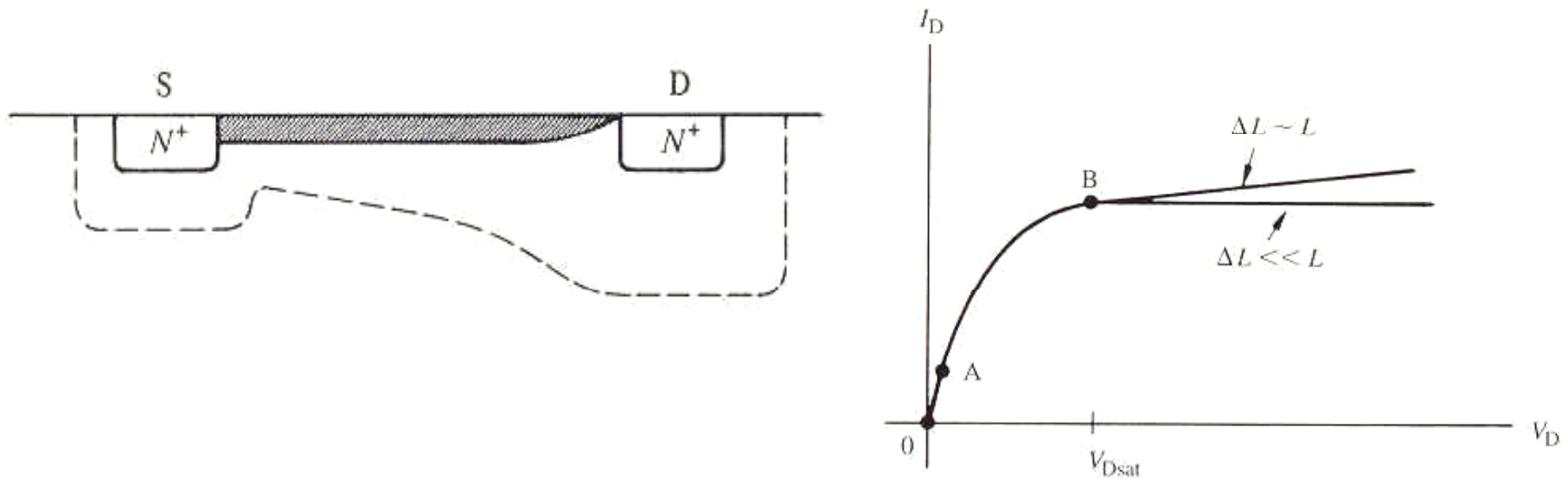
- When  $V_G \leq V_T$ , very few electrons in the channel.  $\approx$  an open circuit between the  $n^+$  region
- When  $V_G > V_T$ ,
  - Inversion layer is formed
  - The conducting channel (induced “n-type” region, inversion layer) connects the D & S
  - $V_G \uparrow \Rightarrow$  the pile up of electrons  $\uparrow \Rightarrow$  conductance  $\uparrow$
- $\therefore V_G$  determines the maximum conductance
- Thermal equilibrium prevails, and  $I_D = 0$



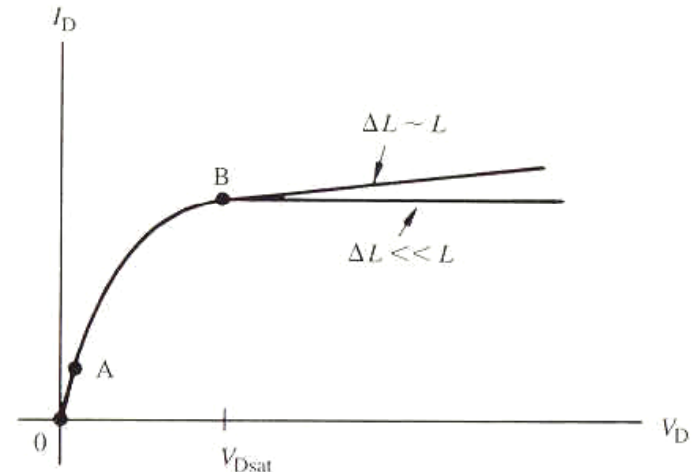
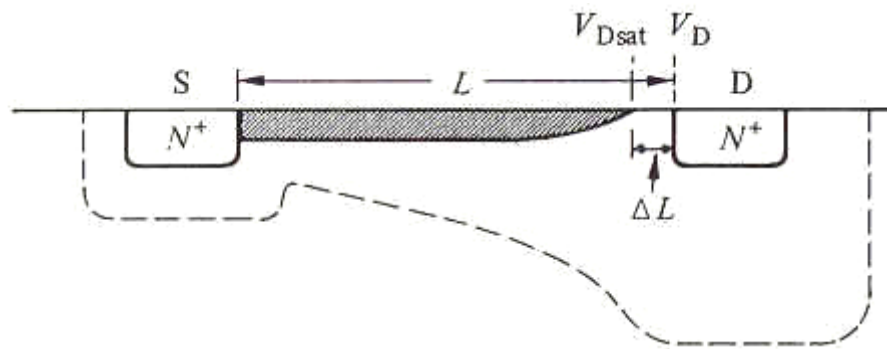
- The  $V_D$  is increased in small steps starting from  $V_D = 0$ 
  - The channel acts like a simple resistor
  - $I_D \propto V_D$
  - The reverse bias junction current is negligible
  - voltage drop from the drain to the source starts to negate the inverting effect of the gate
  - $V_D \uparrow \rightarrow$  Depletion of the channel  $\uparrow \rightarrow$  # of carriers  $\downarrow \rightarrow$  conductance  $\downarrow \rightarrow$  slope-over in the  $I/V$



- **Pinch - off ( $V_D = V_{Dsat}$ )**
  - **Disappearance of the channel adjacent to the drain**
    - **The slope of the  $I_D$ - $V_D$  becomes approximately zero(Point B)**



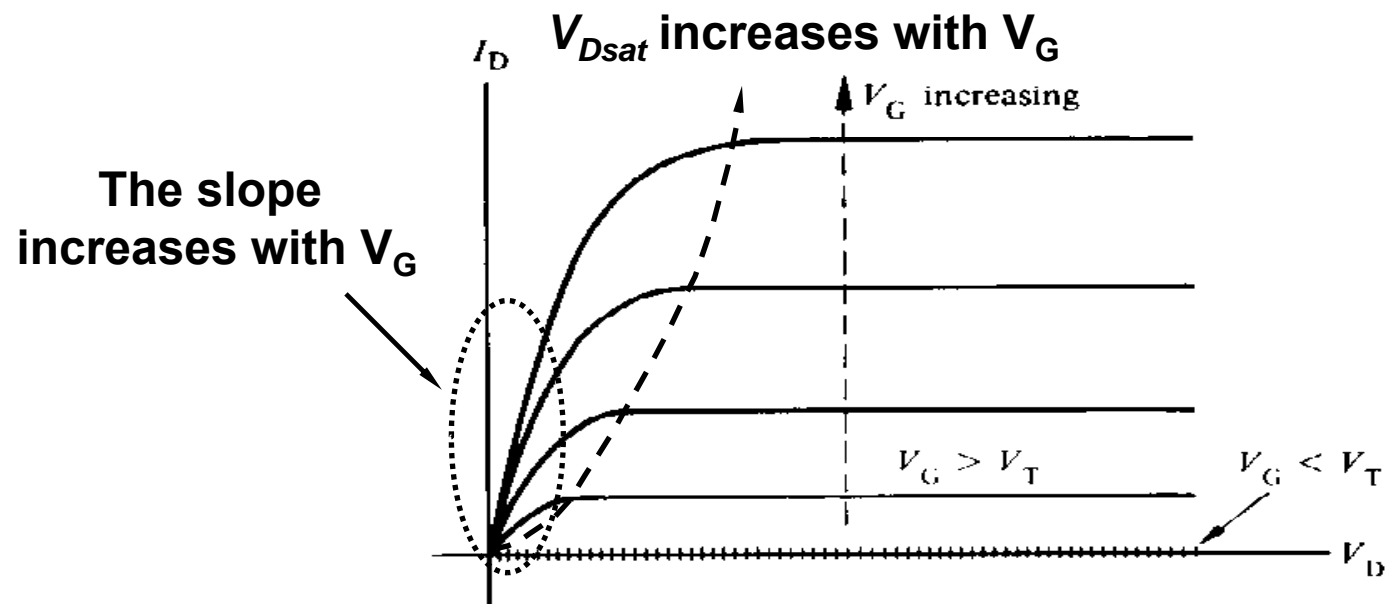
- **Post-pinch-off ( $V_D > V_{Dsat}$ )**
  - The pinched-off portion widens from just a point into a depleted channel section  $\Delta L$
  - The pinched-off section absorbs most of the voltage drop in excess of  $V_{Dsat}$
  - For  $\Delta L \ll L$ , the shape of the conducting region and the potential across the region do not change  
**↙ Constant  $I_D$**
  - For  $\Delta L \sim L$ ,  $I_D$  will increase with  $V_D > V_{Dsat}$





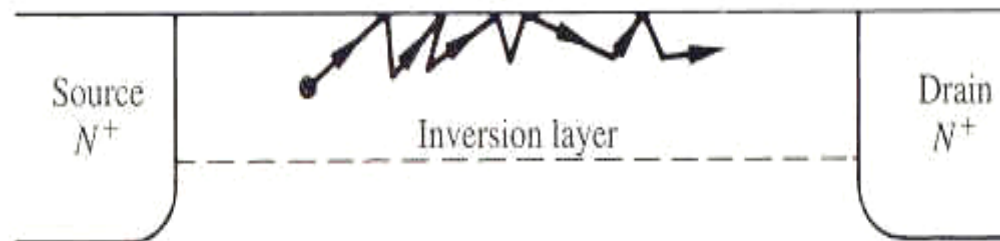
# $I_D - V_D$ Characteristics

- General form of the  $I_D - V_D$  ( $\Delta L \ll L$ )
  - For  $V_G \leq V_T$ ,  $I_D \approx 0$
  - For  $V_G > V_T$ , transistor action:  $I_D$  is modulated by  $V_G$
  - $V_D > V_{Dsat}$ : saturation region
  - $V_D < V_{Dsat}$ : linear(triode) region



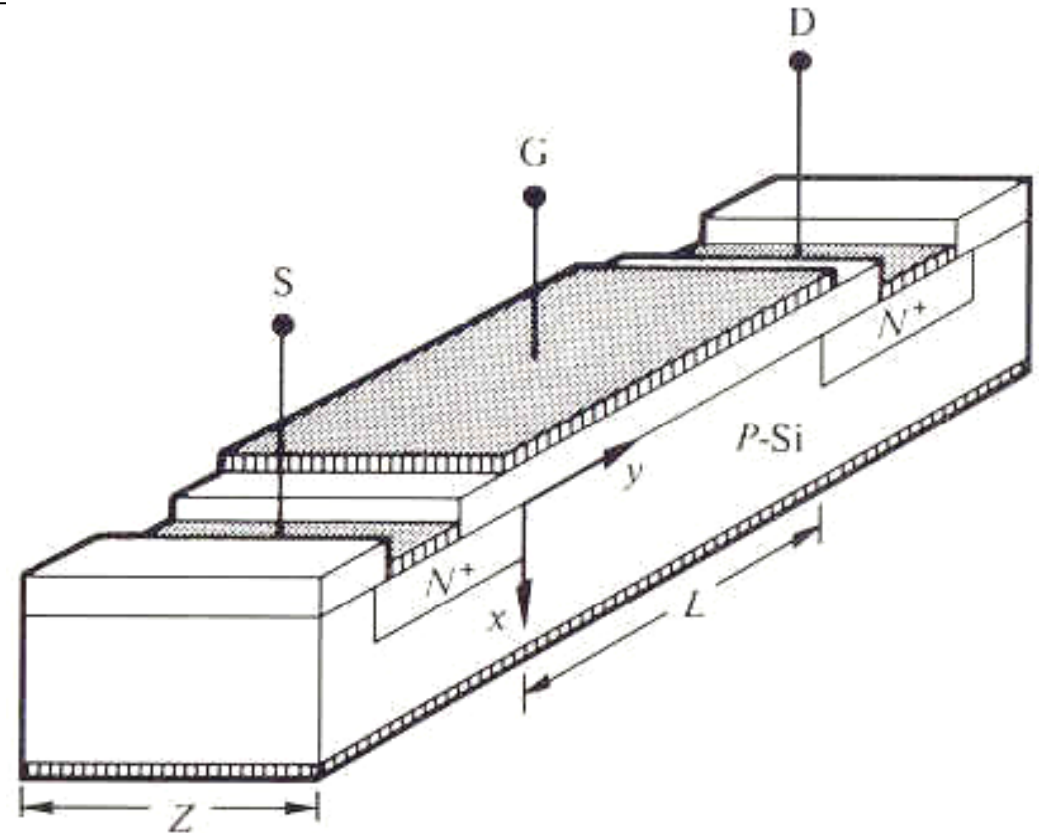
# ***Quantitative $I_D - V_D$ Relationships***

- **Effective Mobility**
  - : Impurity Scattering
  - + Lattice Scattering
  - + Surface Scattering

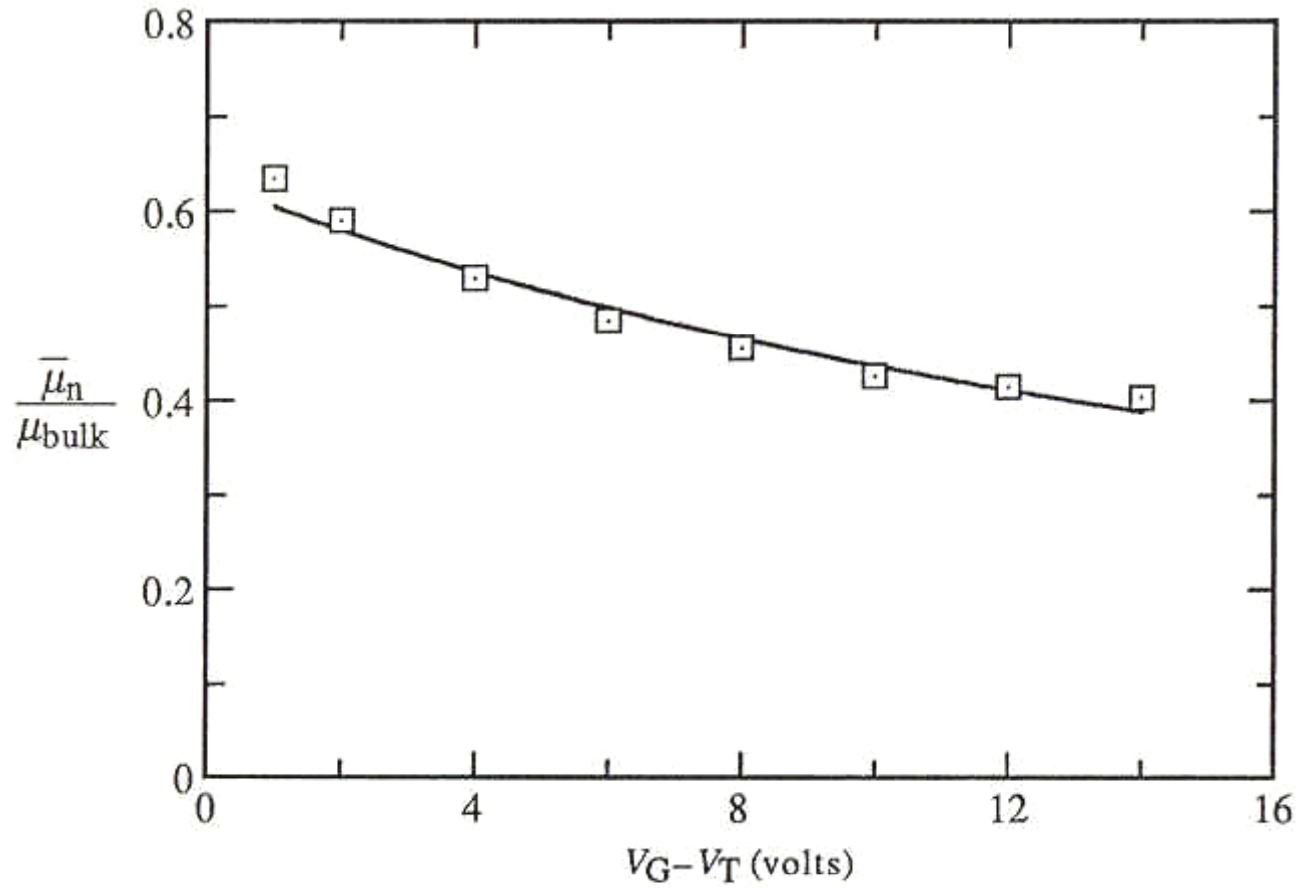


- **Effective Mobility**

$$\bar{\mu}_n = \frac{\int_0^{x_c(y)} \mu_n(x,y) n(x,y) dx}{\int_0^{x_c(y)} n(x,y) dx}$$



–  $V_G \uparrow \rightarrow$   $\left\{ \begin{array}{l} \text{more carriers closer to the interface} \\ \text{higher electric field} \end{array} \right\} \rightarrow \text{surface scattering} \uparrow$   
 $\rightarrow \bar{\mu}_n \downarrow$



- **Square - Law Theory**

- $V_D < V_{Dsat}$

- **A drift current is dominant**

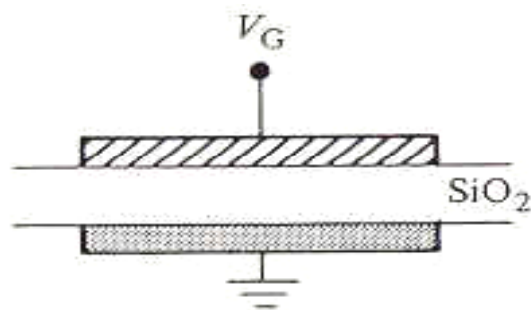
$$Q_{gate} = -Q_{semi} \cong -Q_N$$

$$Q_N \cong -C_o (V_G - V_T)$$

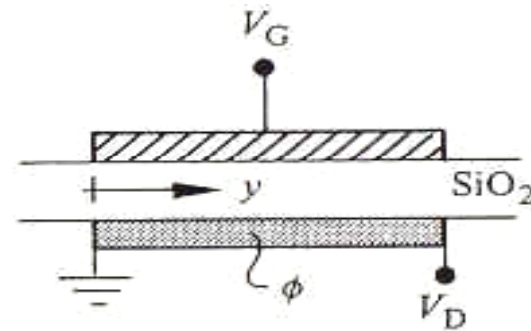
**At an arbitrary point  $y$**

$$Q_N(y) \cong -C_o (V_G - V_T - \phi) \rightarrow I_D = -WQ_N(y)\bar{\mu}_n E(y)$$

$$= W\bar{\mu}_n C_o (V_G - V_T - \phi) \frac{d\phi}{dy}$$



MOS-C



MOSFET

## Integrating

$$\int_0^L I_D dy = W \bar{\mu}_n C_o \int_0^{V_D} (V_G - V_T - \phi) d\phi$$

$$\rightarrow I_D = \frac{W \bar{\mu}_n C_o}{L} \left[ (V_G - V_T) V_D - \frac{V_D^2}{2} \right]$$

- $V_D \geq V_{Dsat}$ 
  - $I_D$  is approximately constant

$$I_{Dsat} = \frac{W\bar{\mu}_n C_o}{L} \left[ (V_G - V_T) V_{Dsat} - \frac{V_{Dsat}^2}{2} \right]$$

$$Q_N(L) = -C_o(V_G - V_T - V_{Dsat}) = 0$$

$$V_{Dsat} = V_G - V_T$$

$$I_{Dsat} = \frac{W\bar{\mu}_n C_o}{2L} (V_G - V_T)^2$$

- **Subthreshold transfer characteristics**

- **At weak inversion, diffusion current dominates**

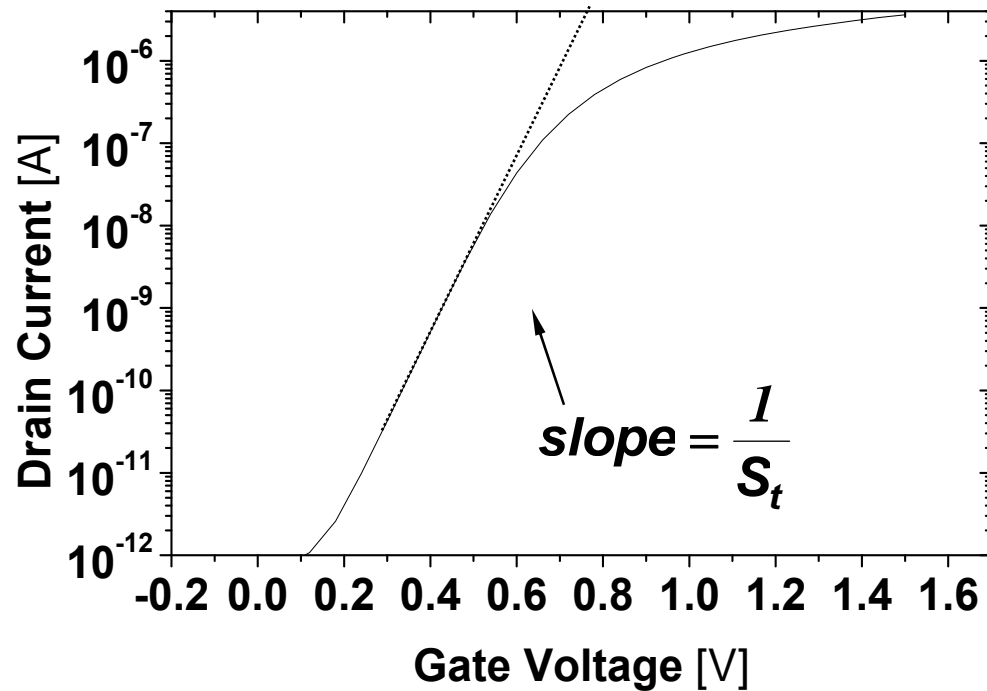
$$I \approx I_{diff} \propto \frac{Q_S - Q_D}{L} \propto \frac{Q_S}{L} \left[ 1 - \exp\left(-\frac{qV_D}{kT}\right) \right]$$

where  $Q_D = Q_S \exp\left(-\frac{qV_D}{kT}\right)$

where  $Q_S$  is exponential function of  $V_G$

- **In long channel MOSFETS the subthreshold current varies exponentially with  $V_G$  and is independent of  $V_D$  provided  $V_D >$  a few  $kT/q$**





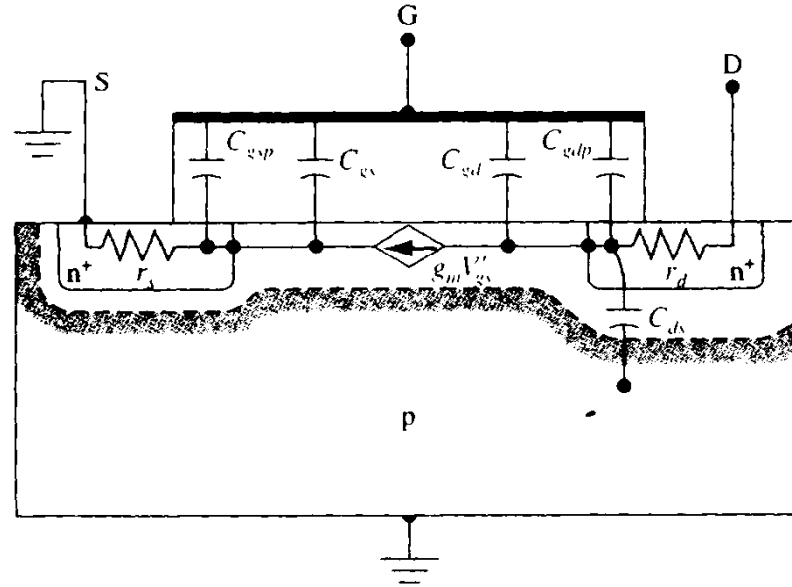
## Subthreshold swing

$$S_t = \frac{1}{\frac{d \log I_D}{dV_G}} \text{ [mV/dec]}$$

= change in  $V_G$

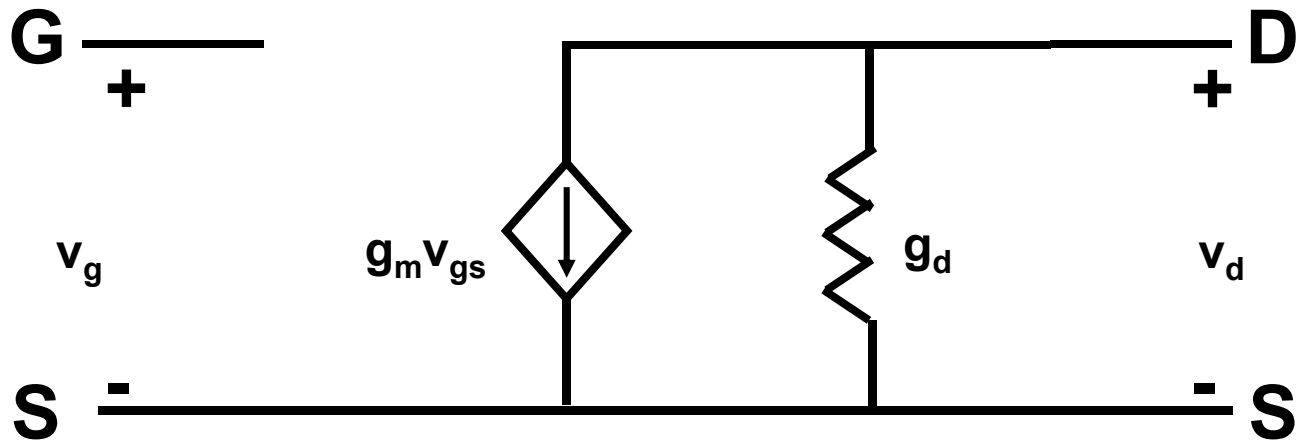
for a decade change in  $I_D$

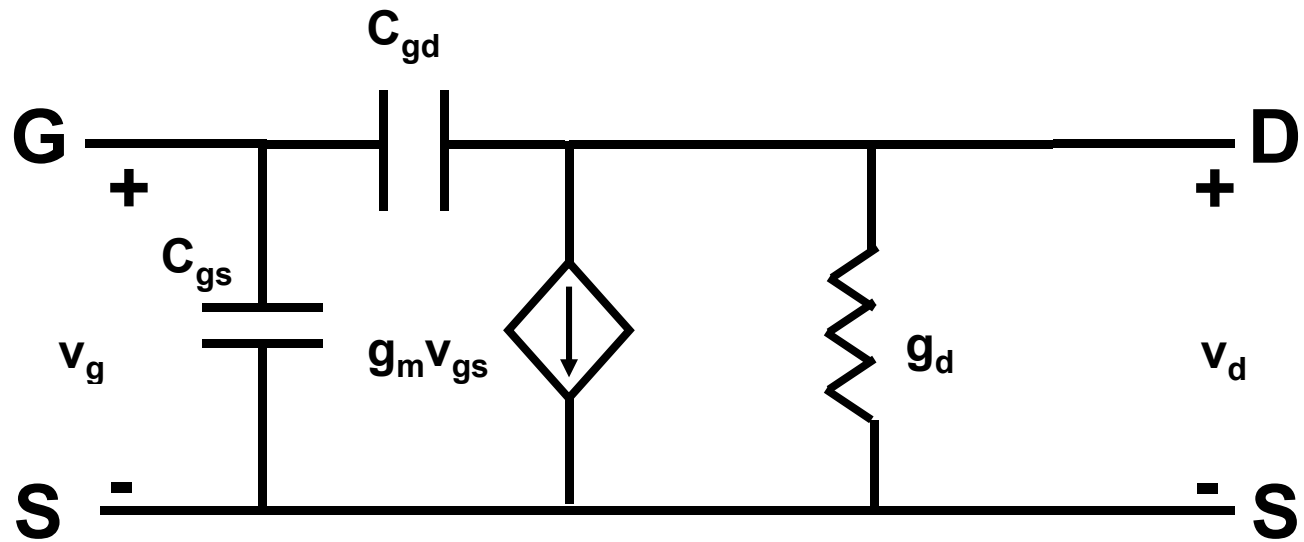
# 17.3 a.c. Response(skip)



- $C_{gs}$  ( $C_{gd}$ ): The interaction between G and the channel charge near S(D)
- $C_{gsp}$ ,  $C_{gdp}$ : parasitic or overlap capacitances

- **Small-signal equivalent circuit**





- **A capacitor behaves like an open circuit at low frequencies.**

- $I_D(V_D, V_G) + i_d = I_D(V_D + v_d, V_G + v_g)$

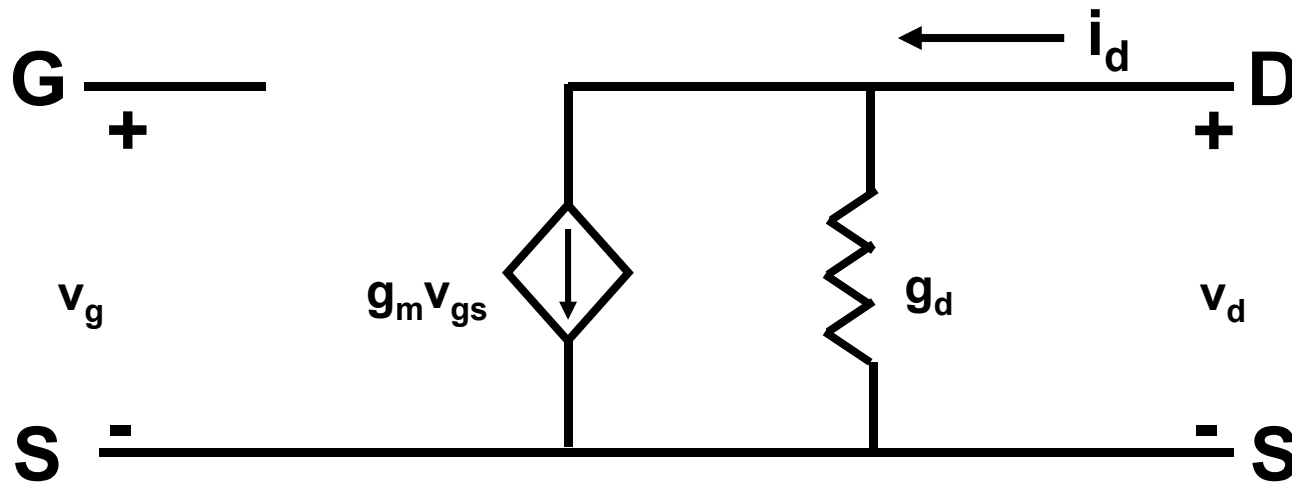
- $i_d = I_D(V_D + v_d, V_G + v_g) - I_D(V_D, V_G)$

$$I_D(V_D + v_d, V_G + v_g) = I_D(V_D, V_G) + \left. \frac{\partial I_D}{\partial V_D} \right|_{V_G} v_d + \left. \frac{\partial I_D}{\partial V_G} \right|_{V_D} v_g$$

$$\therefore i_d = \left. \frac{\partial I_D}{\partial V_D} \right|_{V_G} v_d + \left. \frac{\partial I_D}{\partial V_G} \right|_{V_D} v_g$$

$g_d = \left. \frac{\partial I_D}{\partial V_D} \right _{V_G = \text{constant}}$	<p>...the drain or channel conductance</p>
$g_m = \left. \frac{\partial I_D}{\partial V_G} \right _{V_D = \text{constant}}$	<p>...transconductance or mutual conductance</p>

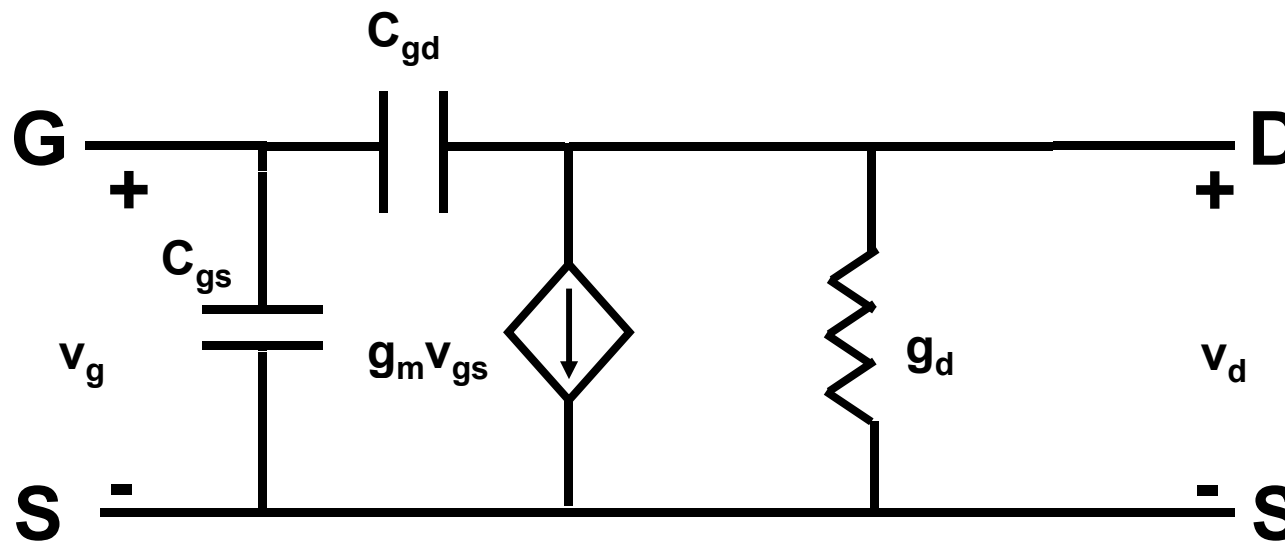
$$\therefore i_d = g_d v_d + g_m v_g$$



- Table 17.1

Below pinch-off ( $V_D \leq V_{Dsat}$ )	Above pinch-off ( $V_D > V_{Dsat}$ )
$g_d = \frac{Z \bar{\mu}_n C_o}{L} (V_G - V_T - V_D)$ $g_m = \frac{Z \bar{\mu}_n C_o}{L} V_D$	$g_d = 0$ $g_m = \frac{Z \bar{\mu}_n C_o}{L} (V_G - V_T)$

- At the higher operational frequencies encountered in practical applications, the circuit must be modified to take into account capacitive coupling between the device terminals.
- The overlap capacitance is minimized by forming a thicker oxide in the overlap region or preferably through the use of self aligned gate procedures. →  $C_{gd}$  is typically negligible.





- **17.3.2. Cutoff Frequency**

The  $f_T$  be defined as the frequency where the MOSFET is no longer amplifying the input signal under optimum conditions.

→ Value of the output current to input current ratio is unity

$$i_{in} = j\omega(C_{gs} + C_{gd})v_g \cong j(2\pi f)C_o v_g$$

$$i_{out} \approx g_m v_g$$

$$|i_{out}/i_{in}| = 1$$

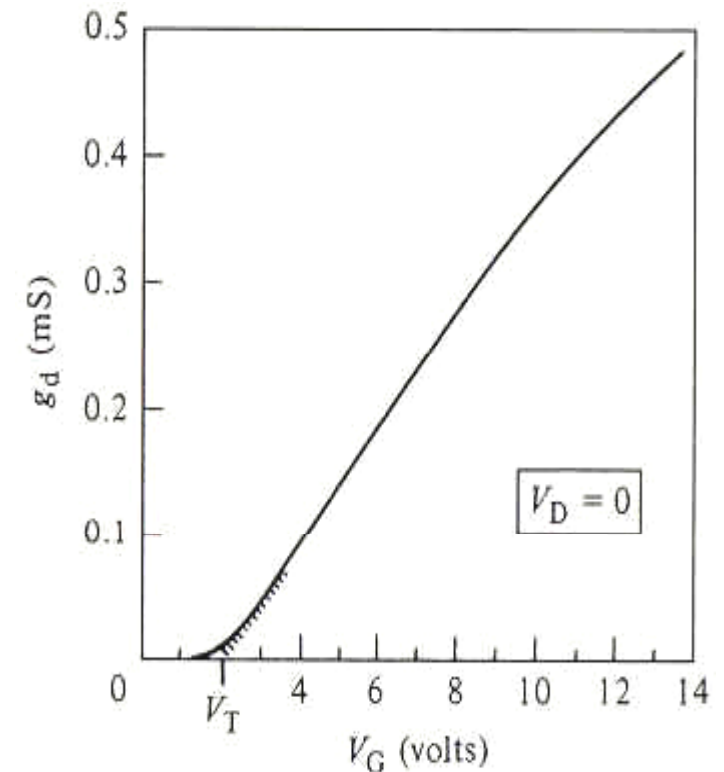
$$\therefore f_T = \frac{g_m}{2\pi C_o} = \frac{\overline{\mu_n} V_D}{2\pi L^2} \quad \text{if } V_D \leq V_{Dsat}$$

# Small Signal Characteristics

- $g_d$  vs.  $V_G$  ( $V_D=0$ )
  - Extrapolating the linear portion of the  $g_d$ - $V_G$  characteristics into the  $V_G$  axis and equating the voltage intercept to  $V_T$

$$g_d = \frac{W\bar{\mu}_n C_o}{L} (V_G - V_T) \quad (V_D=0)$$

- Deduce the effective mobility from the slope



- **Gate Capacitance vs.  $V_G$  ( $V_D=0$ )**

- Diagnostic purposes in much the same manner as the MOS-C  $C-V_G$  characteristics
- Unlike the MOS-C, a low-frequency characteristic is observed even for frequencies exceeding 1MHz
  - Because the source and drain islands supply the minority carriers

